

#29/P/TDS
JP/2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/352,194)
Filed: July 13, 1999)
For: CRYSTALLINE SEMICONDUCTOR)
THIN FILM, METHOD OF FABRICATING)
THE SAME, SEMICONDUCTOR DEVICE,))
AND METHOD OF FABRICATING THE)
SAME)

) Art Unit: 2823
Examiner: F. Toledo

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
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Washington, D.C. 20231, on JUL 16 2002

NOTIFICATION OF RELATED APPLICATIONS

Honorable Commissioner of Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith an attached Form PTO-1449 listing related applications known to Applicant and requests that this information be made of record in the above identified application. Copies of the related applications are submitted herewith in accordance with 37 C.F.R. 1.98(a).

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

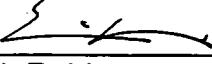
The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,

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